



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 21, 2026

IGI Report Number

DESCRIPTION

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

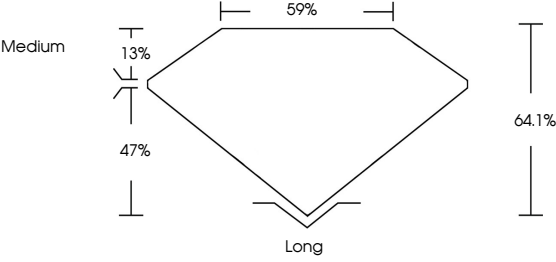
Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

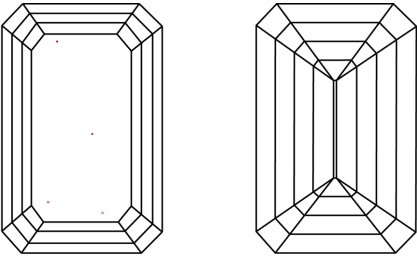
LG819610089

Report verification at [igi.org](#)

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

CLARITY

Sample Image Used



LABORATORY GROWN DIAMOND REPORT

July 21, 2026

IGI Report Number

Description

Shape and Cutting Style

Measurements

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

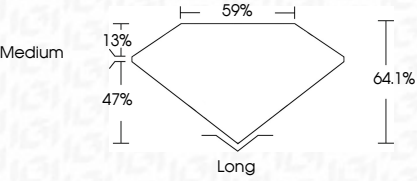
Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

LG819610089

Report verification at [igi.org](#)

PROPORTIONS



COLOR

CLARITY

Sample Image Used



LABORATORY GROWN DIAMOND REPORT

July 21, 2026

IGI Report No LG819610089

EMERALD CUT

8.11 X 5.38 X 3.45 MM

1.52 CARAT

E

VVS 2

EXCELLENT

EXCELLENT

NONE

IGI LG819610089

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

IGI



IGI





© IGI 2020, International Gemological Institute

FD - 10 20

IGI





THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINES.

July 21, 2026

IGI Report No LG819610089

EMERALD CUT

8.11 X 5.38 X 3.45 MM

1.52 CARAT

E

VVS 2

64.1%

59%

Medium

Long

EXCELLENT

EXCELLENT

NONE

IGI LG819610089

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

IGI



